



1122.70096

# PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kenichi Shimazaki et al. )  
)  
Serial No.: 10/807,497 )  
)  
Conf. No.: 3046 )  
)  
Filed: March 23, 2004 )  
)  
For: SYSTEM AND METHOD FOR )  
DETERMINATION OF LOAD )  
MONITORING CONDITION AND )  
LOAD MONITORING PROGRAM )  
)  
Art Unit: 2857 )  
)  
Examiner: Robbins, Janet L. )

*I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.*

July 13, 2006

Date

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### AMENDMENT B

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated April 4, 2006, please amend the  
above-identified Application as follows: